		AL	/
	Application No.	Applicant(s)	
	09/944,234	ZAGREBELNY ET AL.	
Notice of Allowability	Examiner	Art Unit	
	Hsien-Ming Lee	2823	
The MAILING DATE of this communication appeal claims being allowable, PROSECUTION ON THE MERITS IS herewith (or previously mailed), a Notice of Allowance (PTOL-85) NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT R of the Office or upon petition by the applicant. See 37 CFR 1.313	(OR REMAINS) CLOSED in or other appropriate comm IGHTS. This application is	n this application. If not included unication will be mailed in due course. THIS	
1. \square This communication is responsive to $7/2/2004$.			
2. X The allowed claim(s) is/are 1,2,4-8,12-16 and 24-26.			
3. $igotimes$ The drawings filed on <u>31 August 2001</u> are accepted by the	e Examiner.		
4.	e been received. e been received in Application of the communication to file MENT of this application. Initted. Note the attached EX res reason(s) why the oath of the submitted. Son's Patent Drawing Reviews Amendment / Comment of the header according to 37 Chasit of BIOLOGICAL MAT	on No d in this national stage application from the a reply complying with the requirements AMINER'S AMENDMENT or NOTICE OF a declaration is deficient. W (PTO-948) attached r in the Office action of the drawings in the front (not the back) of FR 1.121(d). ERIAL must be submitted. Note the	
Attachment(s) 1. ☐ Notice of References Cited (PTO-892) 2. ☐ Notice of Draftperson's Patent Drawing Review (PTO-948) 3. ☐ Information Disclosure Statements (PTO-1449 or PTO/SB/C Paper No./Mail Date 4. ☐ Examiner's Comment Regarding Requirement for Deposit of Biological Material	6. ☐ Interview S Paper No. 08), 7. ☐ Examiner's	nformal Patent Application (PTO-152) Summary (PTO-413), /Mail Date s Amendment/Comment s Statement of Reasons for Allowance	
		HSIEN-MING LEE PRIMARY EXAMINED	

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DETAILED ACTION

Remarks

1. The 103(a) rejection, as set forth in the previous Office Action, is withdrawn.

Allowable Subject Matter

- 2. Claims 1-2, 4-8, 12-16 and 24-26 are allowed.
- 3. The following is an examiner's statement of reasons for allowance:

The prior art of record, Kim et al. to US 6,484,300 teach a related method, as stated in the previous Office Action. In contrast, Kim et al. neither teach nor suggest *measuring* a pattern density of a layer *prior to* calculating polish time and polishing the layer. Saka et al. to US 6,476,921 do not remedy the deficiency in Kim et al. for the same reason. Applicants' arguments against the cited references are persuasive.

Therefore, the instant invention is neither anticipated nor rendered obvious over the prior art of record.

- 4. Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."
- 5. Any inquiry concerning this communication or earlier communications from the examiner should be directed to Hsien-Ming Lee whose telephone number is 571-272-1863. The examiner can normally be reached on Tuesday-Thursday ($8:00 \sim 6:30$).

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If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Olik Chaudhuri can be reached on 571-272-1855. The fax phone number for the organization where this application or proceeding is assigned is 703-872-9306.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

Hsien-Ming Lee Primary Examiner Art Unit 2823

September 8, 2004

HSIEN-MING LEE PRIMARY EXAMINATE 9/8/2014